



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4125

<b>SERIAL NUMBER</b> 10/668,186	<b>FILING OR 371(c) DATE</b> 09/24/2003 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> 1248-0673P	
<b>APPLICANTS</b> Yutaka Takafuji, Nara-shi, JAPAN; Takashi Itoga, Nara-shi, JAPAN; <i>Lee</i>					
<b>** CONTINUING DATA *****</b> <i>Lee</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>Lee</i> JAPAN 2002-280078 09/25/2002 JAPAN 2002-299577 10/11/2002 JAPAN 2003-067109 03/12/2003					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 12/20/2003</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Verified and Acknowledged <i>[Signature]</i> Examiner's Signature <i>[Signature]</i> Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 17	<b>TOTAL CLAIMS</b> 56	<b>INDEPENDENT CLAIMS</b> 14
<b>ADDRESS</b> 2292					
<b>TITLE</b> Single-crystal silicon substrate, SOI substrate, semiconductor device, display device, and manufacturing method of semiconductor device					
<b>FILING FEE RECEIVED</b> 2372	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		